

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

nt: Mark L. Jenson

March 29, 2004

Mark L. Jenson 10/813,321 Savitri Mulpuri

Group Art Unit: 2812

Docket:

Examiner:

1327.009US2

Title: METHOD OF CONTINUOUS PROCESSING OF THIN-FILM BATTERIES AND LIKE DEVICES

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

X This transmittal and a return postcard;

X A Supplemental Information Disclosure Statement (1 page),

X A Form PTO/SB/08A (Substituted for Form 1449) (1 page);

 $\underline{X}$  Copies of  $\underline{4}$  cited references.

If not provided for in a separate paper filed herewith, please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 502931.

LEMAIRE PATENT LAW FIRM, PLLC.

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<u>PATENT</u>

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mark L. Jenson Examiner: Savitri Mulpuri Serial No.: 10/813,321 Group Art Unit: 2812

Filed: March 29, 2004 Attorney Docket: 1327.009US2
Title: METHOD OF CONTINUOUS PROCESSING OF THIN-FILM BATTERIES AND LIKE DEVICES

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicant respectfully requests that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form PTO/SB/08A (Substitute Form 1449) be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicant requests that a copy of the PTO/SB/08A form, initialed as being considered by the Examiner, be returned to the Applicant with the next official communication.

Pursuant to the *sua sponte* "Waiver of Copy Requirements" issued by the USPTO September 21, 2004, copies of cited U.S. patent applications are not required to be provided with an IDS for applications stored in the USPTO's IFW system. If copies of cited U.S. patent applications or U.S. issued patents are required for this application, please notify the Applicant's Representative.

Pursuant to 37 C.F.R. §1.97(b), Applicant believes that no fee is due for this Supplemental Information Disclosure Statement. Please charge any additional fees or credit any overpayment to Deposit Account No. 502931. The Examiner is invited to contact the Applicant's Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted, MARK L. JENSON By his Representatives,

LEMAIRE PATENT LAW FIRM, PLLC P.O. Box 11358 St. Paul, MN 55111

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Date Dichember 2014 By

Charles A. Lemaire

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Complete if Known Substitute for form 1449A/PTO
INFORMATION DISCLOSURE
TATEMENT BY APPLICANT 10/813,321 **Application Number** March 29, 2004 **Filing Date** (Use as many sheets as necessary) Mark L. Jenson, **First Named Inventor** 2812 **Group Art Unit** Savitri Mulpuri **Examiner Name** Attorney Docket No: 1327.009US2 Sheet 1 of 1

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	OTHER DOCUMENTS NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T*			
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**DATE CONSIDERED EXAMINER**